



△				APPROVED	CHECKED	MATERIAL 材料		CHAMFER 一般面取		QUANTITY 個數
△				T. A.	T. A.	TREATMENT 処理		FINISHING 仕上		
△				DESIGNED	DRAWN	TREATMENT CONTACT 処理接点		DECENTRATION 偏芯		
△				T. A.	S. K.	OVER 250 UP TO 1000 ±0.3 ±0.5 ±1.0 ±0.2	UNIT (mm)	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)
△						OVER 63 UP TO 250 ±0.2 ±0.3 ±0.6 ±0.15				VS-TCH1-65C0
△						OVER 16 UP TO 63 ±0.1 ±0.2 ±0.4 ±0.1	SCALE	1 / 1	NAME	外觀圖
△						OVER 0 UP TO 16 ±0.05 ±0.1 ±0.2 ±0.1	DATE	'09.04.02	DRAW NO.	ODT C0417A1
	DATE	EXCH NO.	REVISION 変更記事			TOLERANCES	A	B	C	S